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PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:

TOSHIHIKO TAKEDA ET AL.

Application No.: 10/774,583

Filed: February 10, 2004

For: METHOD AND APPARATUS FOR
PRODUCING ELECTRON SOURCE

Examiner: M.B. Cleveland

Group Art Unit: 1762

August 1, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR ACKNOWLEDGMENT OF
PREVIOUSLY CITED ART

Sir:

In the Office Action dated March 30, 2005, the Examiner requested new copies of foreign patent documents JP-07-235255 and KR 1996-0039066. These documents were cited in the Information Disclosure Statement filed February 10, 2004, but no copies of the documents were provided because they were submitted in the parent of the present application (see MPEP §609). The Office Action stated that these documents were not found in the file wrapper of parent application Ser. No. 09/788,411, which is now U.S. Patent No. 6,726,520.

In accordance with the Examiner's request, Applicants enclose herewith, a copy of each of JP-07-235255 (an English-language translation thereof also is submitted

herewith) and KR 1996-0039066 (counterpart to U.S. Patent No. 5,578,906, of record). In addition, as evidence of prior submission, Applicants have enclosed a copy of the initialized Form PTO-1449 of record in the parent application, indicating that the above mentioned non-English documents and the mentioned English translation were received and considered by Examiner Kenneth J. Ramsey of the Patent and Trademark Office.

It is respectfully requested that JP-07-235255, its English translation, and KR 1996-0039066 be considered by the Examiner and that a copy of Form PTO-1449 submitted with the February 10, 2005 Information Disclosure Statement be returned with the Examiner's initials indicating that these references have been considered.

Since JP-07-235255 and KR 1996-0039066 were originally submitted in the parent application, no fee is believed due with this paper.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

APPLICANT

Toshihiko Takeda et al.

LIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

FILING DATE

February 21, 2001

GROUP

2879

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
K/h	5,578,906	11/26/96	Smith	315	169.3	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
K/h	1996-0039066	11/21/96	Korea	H01J	17/12	U.S. Counterpart 5,578,906
K/h	08-007749	01/12/96	Japan	H01J	9/02	Trans.
K/h	08-045416	02/16/96	Japan			Trans.
K/h	09-293469	11/11/97	Japan			Trans.
K/h	09-330653	12/22/97	Japan			Trans.
K/h	05-114644	05/07/93	Japan			Trans.
K/h	08-171849	07/02/96	Japan			Trans.
K/h	07-235255	09/05/95	Japan			Trans.

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

Kenneth J. Ramsey
Primary Examiner

DATE CONSIDERED

4/21/03

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

